Amendments to the Claims:

The following listing of claims will replace all prior versions, and listings, of claims in the application:

- 1. (Currently Amended) A method of adjusting the optical thickness of an optical emponental lens made from a material transparent to light to be used, comprising; etching a surface of said optical component the lens to reduce said the optical thickness.
- 2. (Currently Amended) A method of adjusting the position of an optical component, comprising;

etching a <u>mounting</u> surface of <u>saidthe</u> optical component to adjust the position of <u>the</u> optical component at least one surface thereof.

- 3. (Currently Amended) An optical component A lens whose optical thickness has been adjusted by the thickness adjustment method of Claim 2a method according to Claim 1.
- 4. (Currently Amended) An optical component whose <u>mounting surfaceoptical</u> thickness has been adjusted by the thickness adjustment method of Claim 4a method according to Claim 2.
- 5. (New) A method of adjusting the optical thickness of a lens according to Claim 1, further comprising:

manufacturing the lens before etching the surface of the lens to reduce the optical thickness.

6. (New) A method of adjusting the optical thickness of a lens according to claim 5, wherein etching is performed to bring an optical thickness of the manufactured lens to a target optical thickness of the lens.

- 7. (New) A method of adjusting the optical thickness of a lens according to claim 1, wherein the lens comprises a convex surface and a planar surface, and the planar surface is etched to reduce the optical thickness.
- 8. (New) A lens whose optical thickness has been adjusted by a method of according to Claim 5.
- 9. (New) A lens whose optical thickness has been adjusted by a method of according to Claim 6.
- 10. (New) A lens whose optical thickness has been adjusted by a method according to Claim 7.